

531 Rec

09/ 890095  
27 JUL 2001  
2-5-02  
Docket: 740819-603

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re National Phase Patent Application of )  
Gaku SUGAHARA et al. )  
International Application No. PCT/JP00/08461 ) Attn: US/DO/EO  
International Filing Date: November 29, 2000 )  
For: SEMICONDUCTOR LASER DEVICE, )  
METHOD FOR FABRICATING THE )  
SAME, AND OPTICAL DISK APPARATUS ) Date: July 27, 2001

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents  
Washington, D.C. 20231

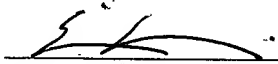
Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

These references were cited in the International Search Report, a copy of which is submitted herewith.

Respectfully submitted,

  
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